

20/91/10

**PATENT NUMBER and
ISSUE DATE**

APPL NUM 10050743	FILING DATE 01/16/2002	CLASS 250 438	SUBCLASS - 1 - - 1	GAU 288 2812	EXAMINER Hosini
**APPLICANTS: Scheuer Jay; Renau Anthony; Hermanson Eric;					
**CONTINUING DATA VERIFIED: <i>yes</i> THIS APPLN CLAIMS BENEFIT OF 60/262,594 01/18/2001					
** FOREIGN APPLICATIONS VERIFIED: <i>none</i>					
PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>			
Foreign priority claimed		<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO	
35 USC 119 conditions met				V0077/7219 WRM	
Verified and Acknowledged Examiners's initials		<i>W</i>			
TITLE : Adjustable conductance limiting aperture for ion implanters					
U.S. DEPT. OF COMM. / PAT. & TM. PTO-435L (Rev. 12-94)					

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Assistant Examiner	Total Claims _____ Print Claim for O.G. _____
ISSUE FEE		Primary Examiner	DRAWING
Amount Due	Date Paid		Sheets Drawg. _____ Figs. Drawg. _____ Print Fig. _____
<input type="checkbox"/> TERMINAL DISCLAIMER		Application Examiner	
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